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| DATE: | August 17, 2001 | FILE NO: | AMAT/3049/CPES/DT/PJS | | |
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| то: | Examiner Lan Vinh | | FAX NO: | (703) 305 -8599- 6018 | |
| COMPANY: | United States Patent and Trademark Office | | | | |
| FROM: | Robb D. Edmonds | | PAGE(S): with cover | 8 | |
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RESPONSE TO FINAL OFFICE ACTION DATED JUNE 5, 2001

U.S. Serial No.

09/206,027

Filing Date:

December 4, 1998

Inventor:

Cohen, et al.

Examiner:

L. Vinh

Group Art Unit:

1765

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Any. Dkt. No. AMAT/3049/CPES/DT/PJS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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in re Application of:

Cohen, et al.

Serial No.: 09/206,027

Confirmation No.: 4950

Filed:

December 4, 1998

For:

Plasma Preclean With Argon, Helium, and Hydrogen Gases

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit: 1765

Examiner:

L. Vinh

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as anached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner namely, Lan Vinh, fax number (703) 305-3599 to the attention of the named Examiner, on the date below

Signature

RESPONSE TO FINAL OFFICE ACTION DATED JUNE 5, 2001

In response to the Final Office Action dated June 5, 2001, having a shortened statutory period for response set to expire on September 5, 2001, please enter the following amendments and reconsider the claims pending in the application for reasons discussed below. The Commissioner is authorized to charge Deposit Account No. 20-0782/AMAT/3049/BTP, along with any other fees to make this response timely.

IN THE CLAIMS:

The pending claims are as follows:

A method for processing a substrate in a processing chamber, comprising exposing a patterned substrate surface to a plasma generated from a gas mixture consisting of argon, helium and hydrogen, wherein the gas mixture comprises less than about 75% by volume of argon.

Page 1